



THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE APPLICATION OF:

Applicant: Richard T. Takeuchi and
Robert M. Nakamura

Serial No.: 10/617,861

Filed: July 14, 2003

Art Unit: 3806

Date: January 9, 2006

Examiner: John Kreck

For: SUBTERRANEAN WASTE DISPOSAL PROCESS AND SYSTEM

RESPONSE

The Honorable Commissioner of Patents and Trademarks

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This is responsive to the Official Action dated September, 14, 2005 relating to the above-identified application.